

<b>Notice of References Cited</b>			Application/Control No. 09/871,467	Applicant(s)/Patent Under Reexamination CHEN ET AL.
Examiner Katarzyna Wyrozebski Lee		Art Unit 1714		Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-5,035,936	07-1991	Dockrill et al.	428/96
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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